

Cryogenic GaAs cathodes development for improved lifetimes



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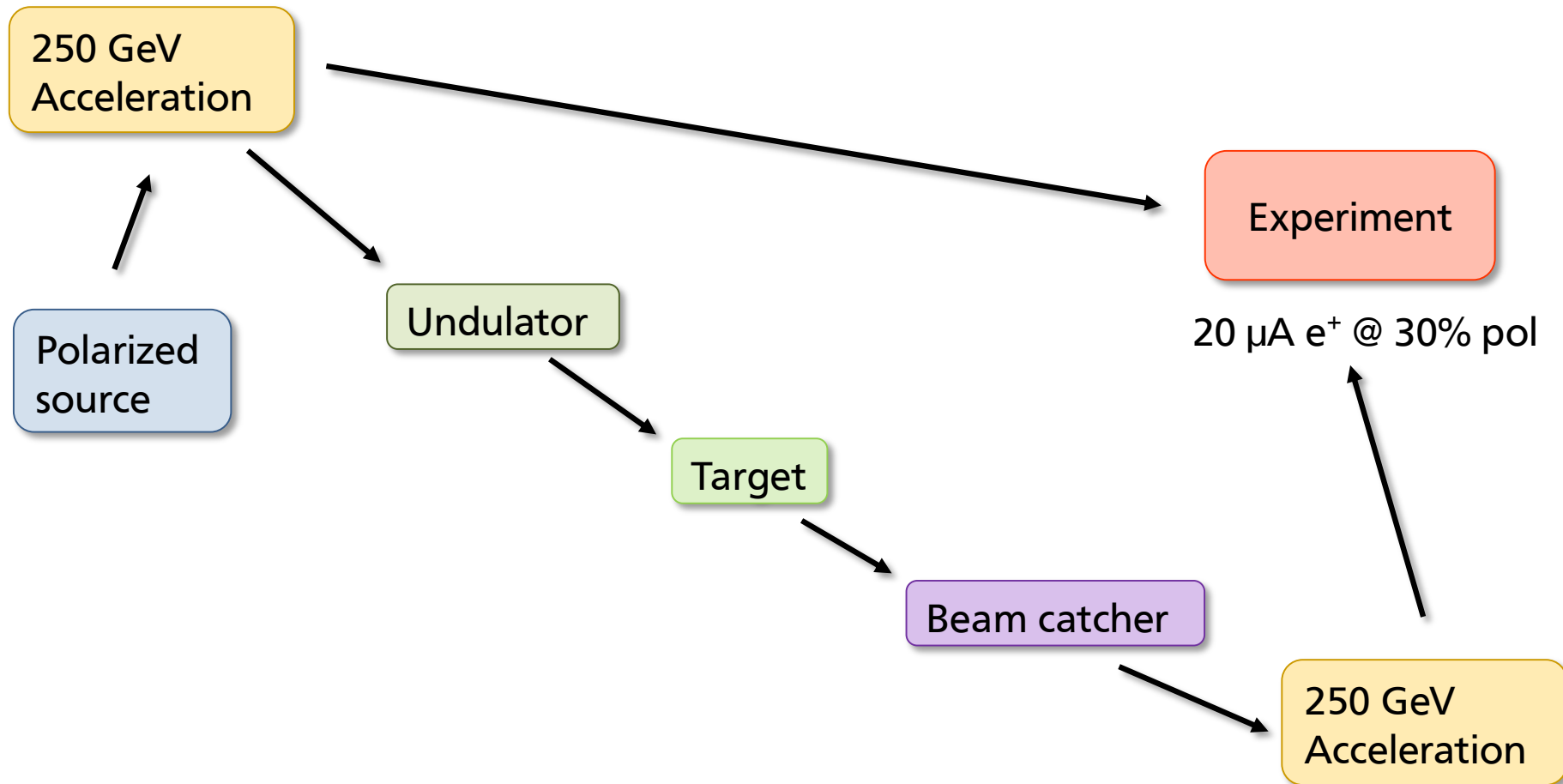
Tobias Eggert, Joachim Enders, Yuliya Fritsche

supported by DFG (GRK 2128) and BMBF (05H18RDRB1)



Motivation

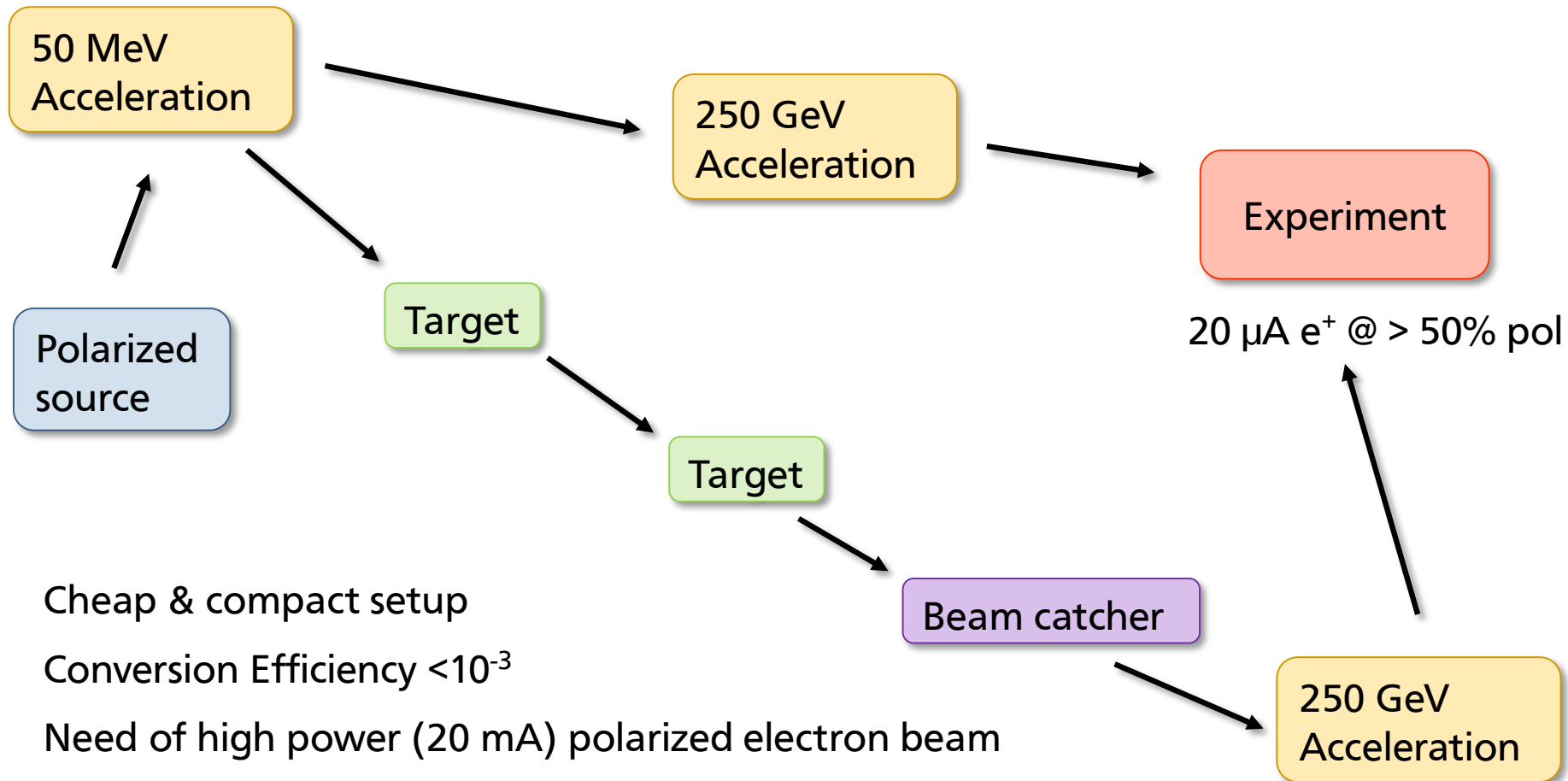
ILC positron beam plan



- Need of very **expensive** undulator!

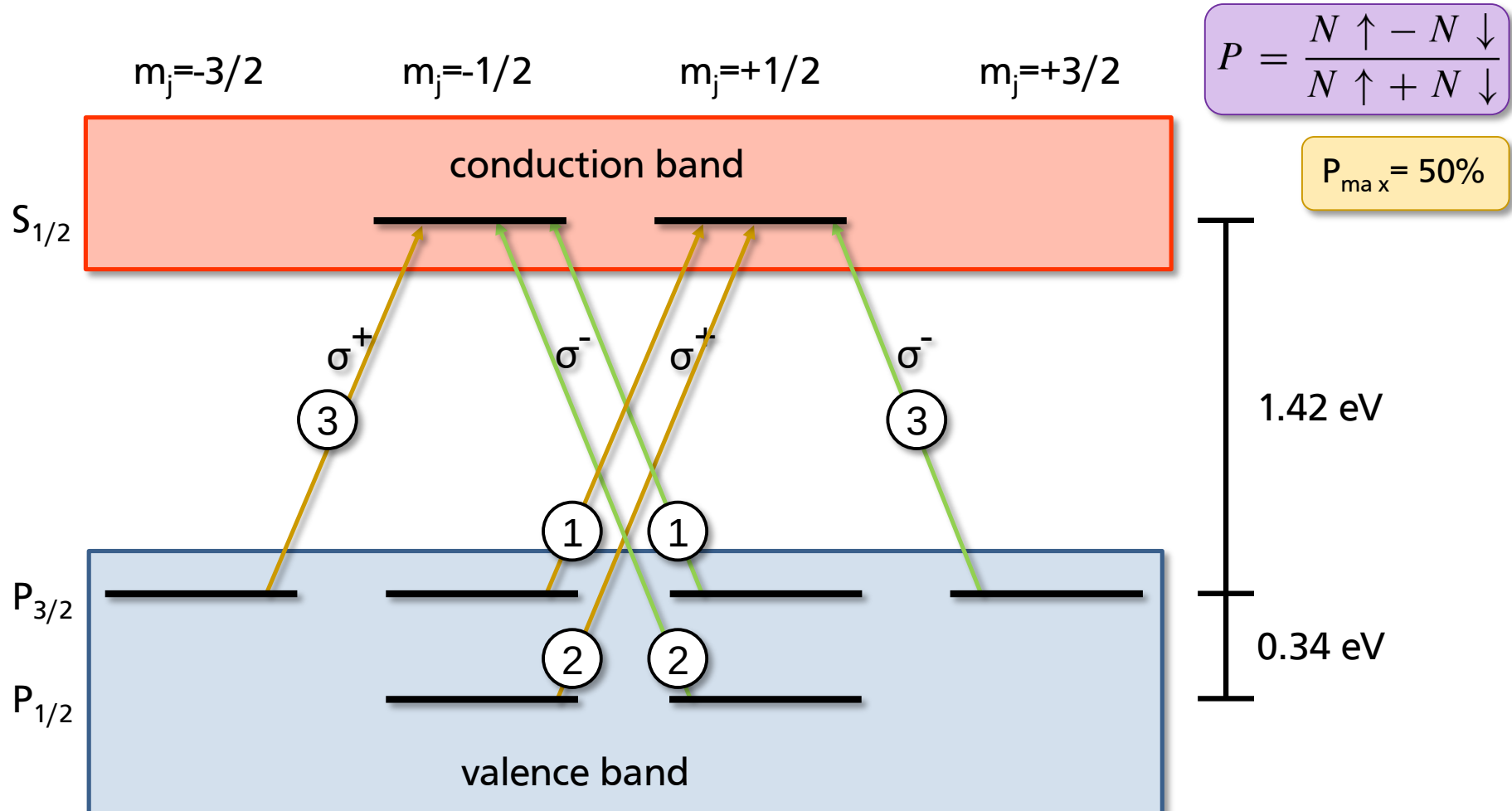
Motivation

ILC polarized positron source



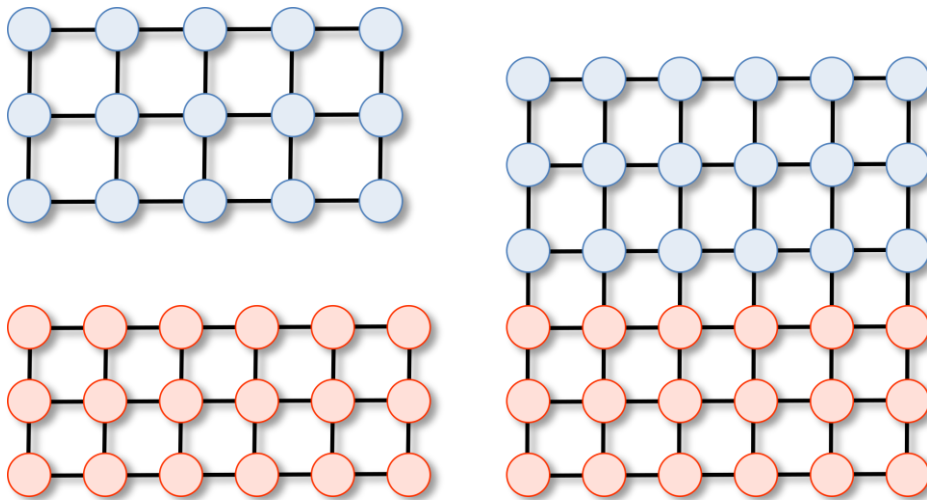
- Cheap & compact setup
- Conversion Efficiency $< 10^{-3}$
- Need of high power (20 mA) polarized electron beam
- Charge lifetime ~ 1 week $\rightarrow \approx 10\,000$ C (Darmstadt: 10 C)

Principle of generating polarized electrons

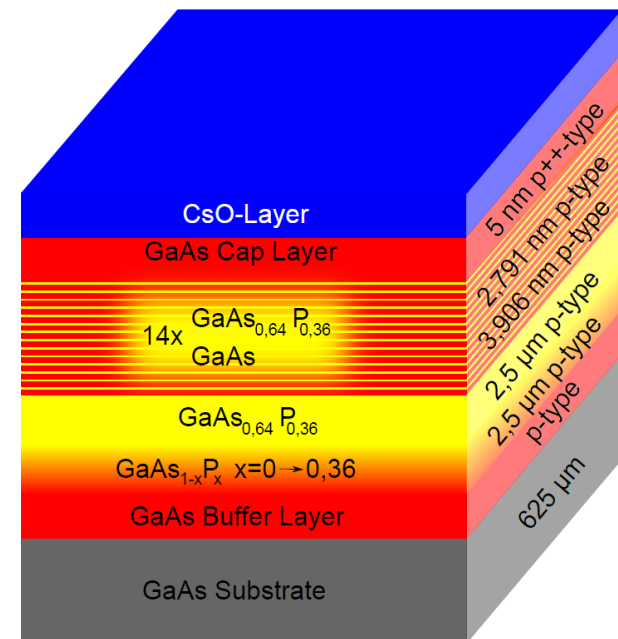


Principle of generating polarized electrons

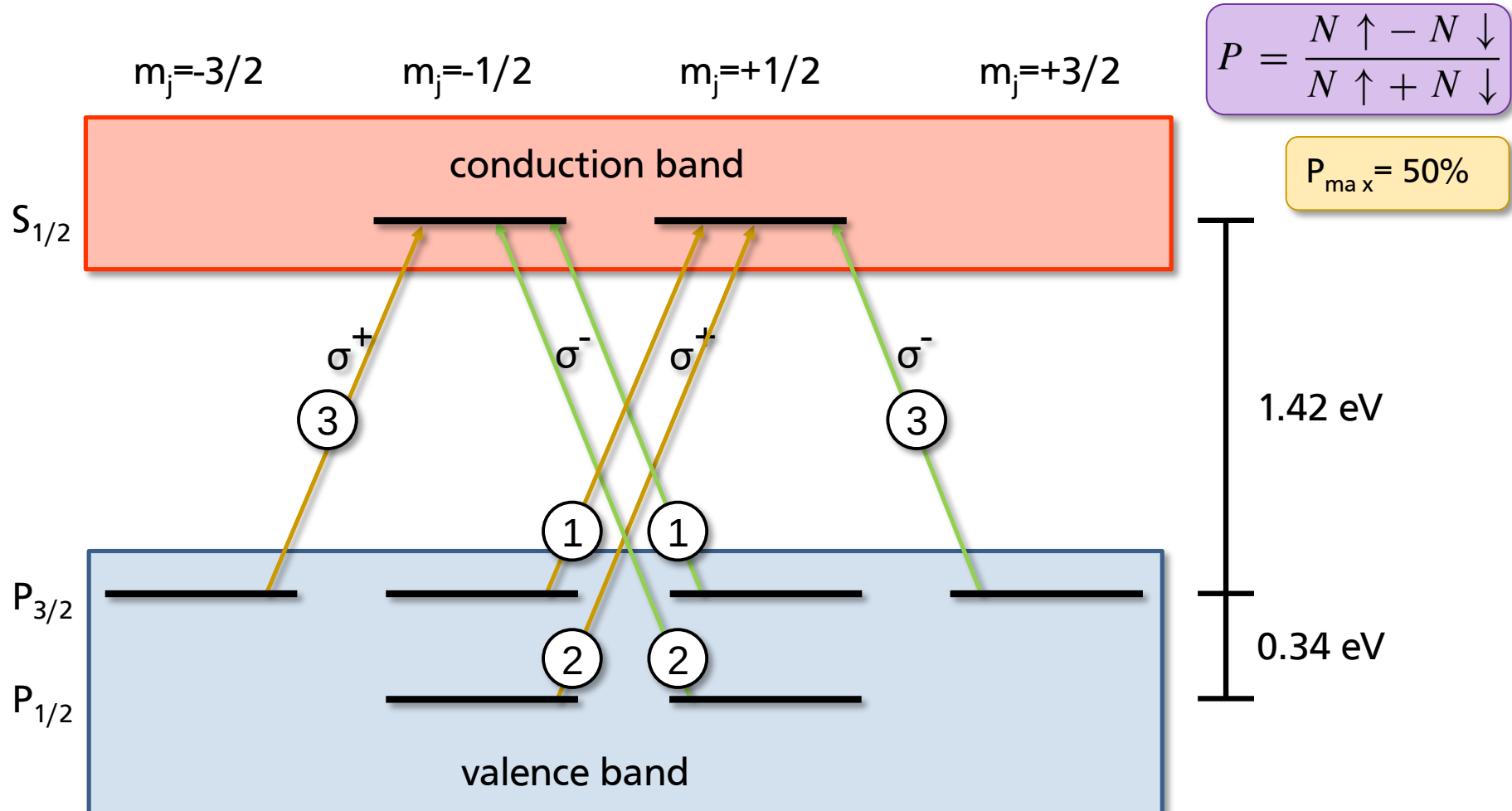
GaAs



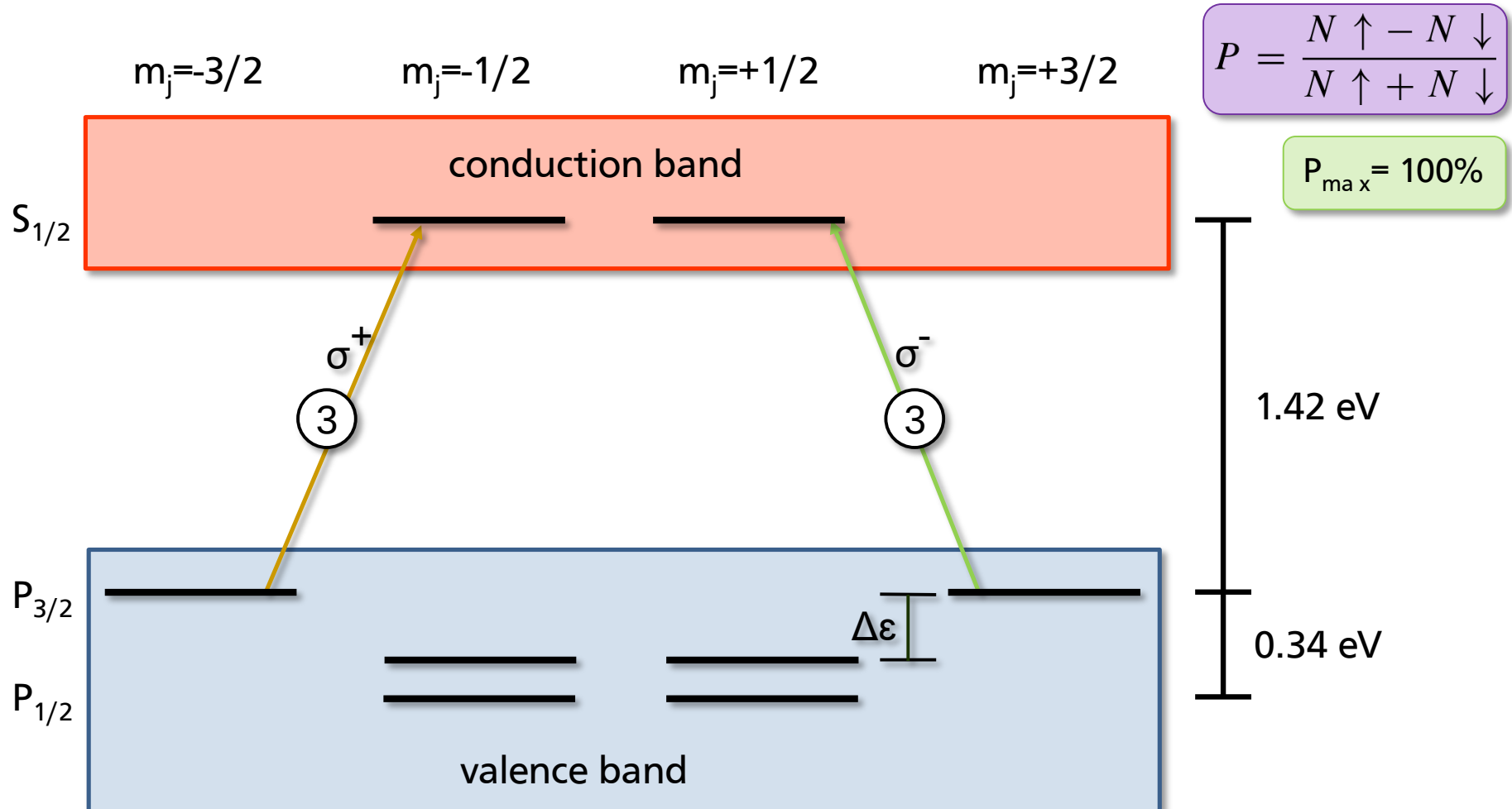
substrat



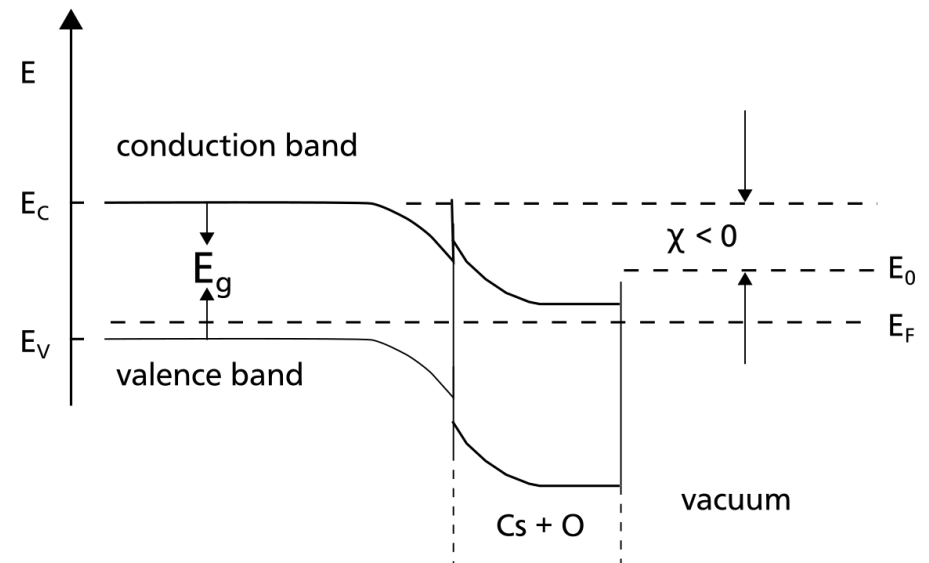
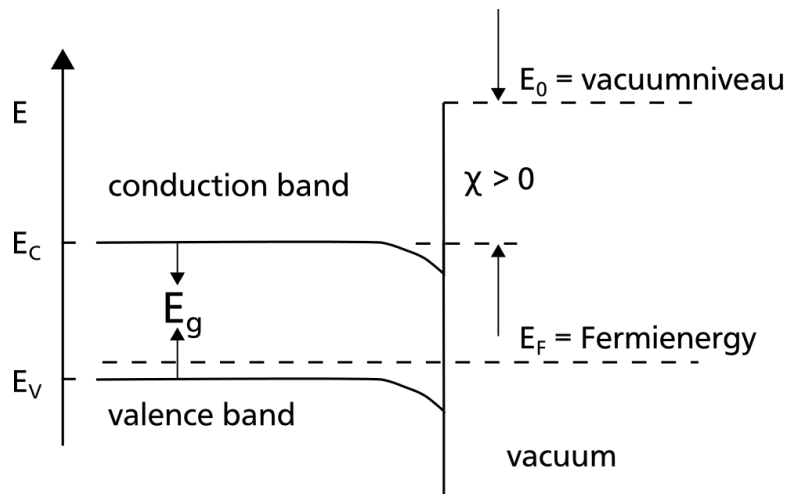
Principle of generating polarized electrons



Principle of generating polarized electrons



Negativ electron affinity



Cathode lifetime

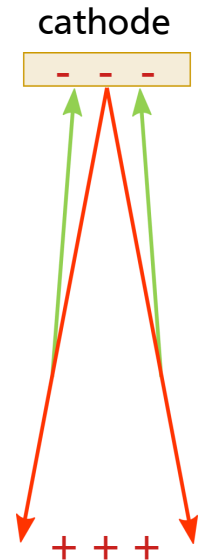
$$\frac{1}{\tau} = \sum_i \frac{1}{\tau_i} = \underbrace{\frac{1}{\tau_{VAC}} + \frac{1}{\tau_{FE}}}_{\text{Charge-free lifetime}} + \underbrace{\frac{1}{\tau_{LOSS}} + \frac{1}{\tau_{IBB}}}_{\text{Charge lifetime}}$$

Vacuum lifetime:
Better vacuum
conditions

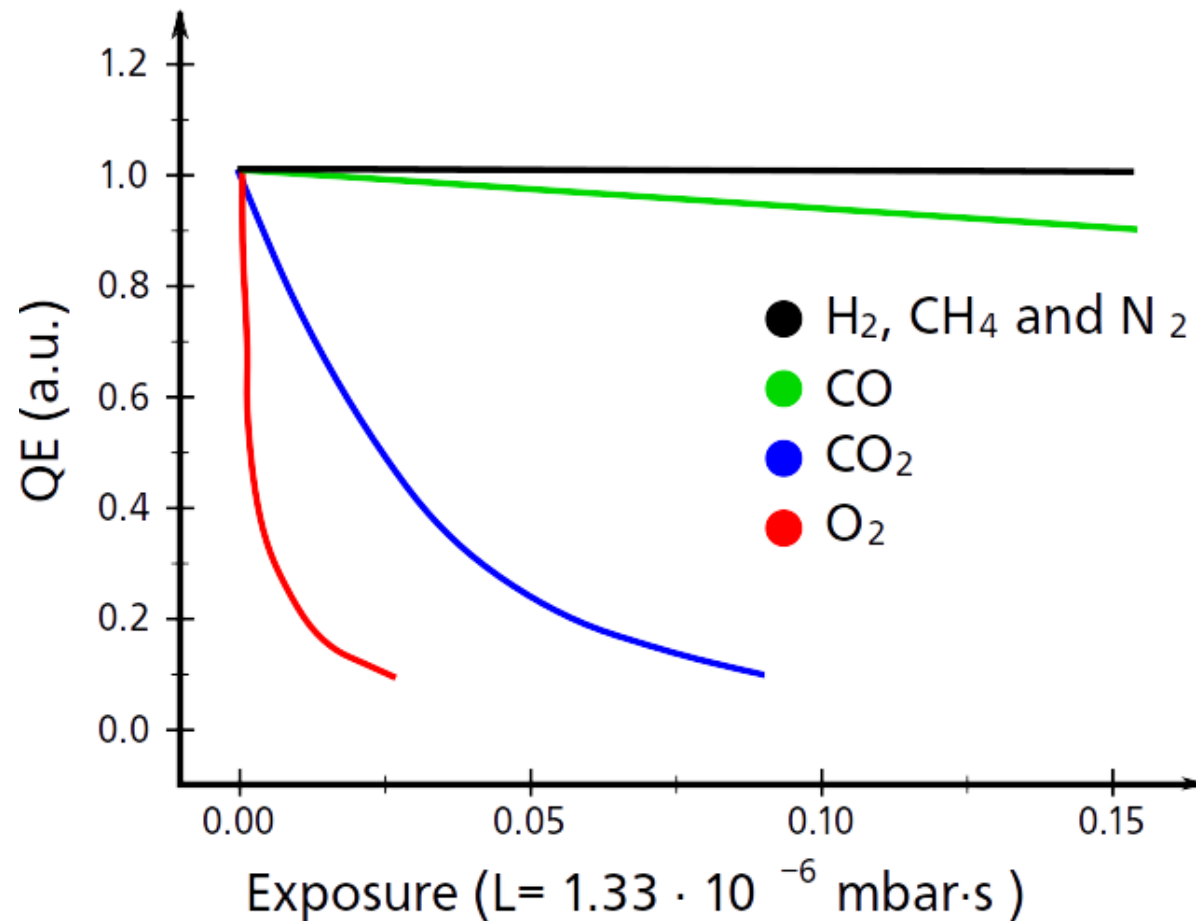
Field emission:
Electrode design

Particle losses:
Small emittance

**Ion back
bombardment:**
Better vacuum
conditions

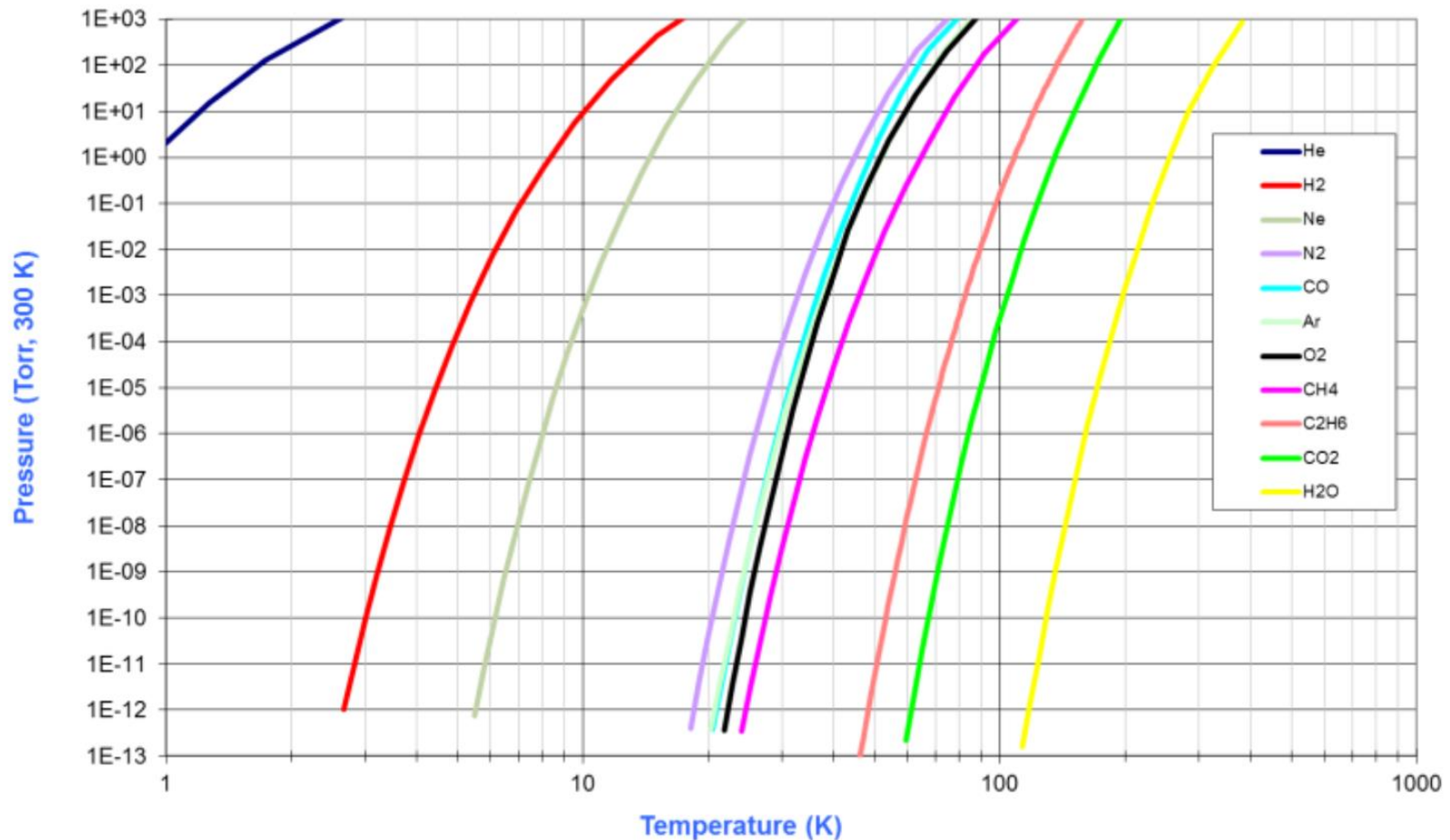


Cathode lifetime



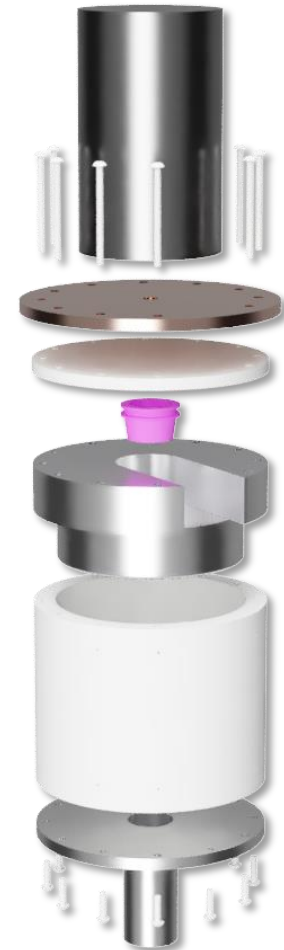
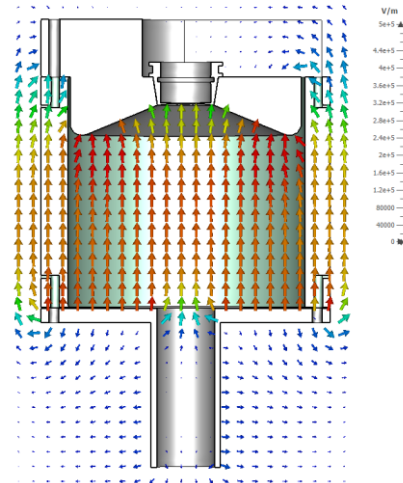
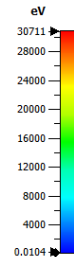
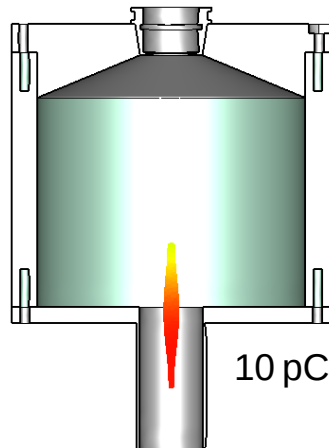
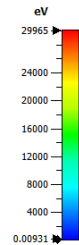
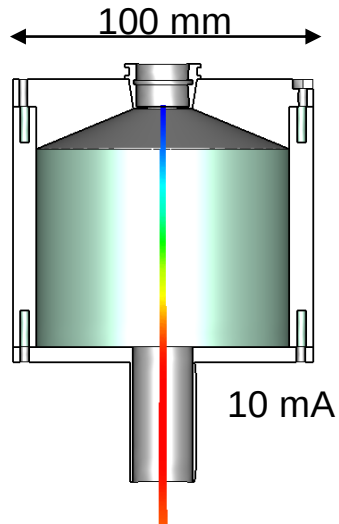
J. Phys. D: Appl. Phys. 47 (2014) 055110

Better vacuum conditions with cryopumping



Honig, Hook, Vapor pressure data for some common gases

Source Design



Expected vacuum conditions

$$S = 1000c(T_{in})A\sqrt{\frac{8k_bT_{out}}{m\pi}}$$

$c(T_{in})$: sticking-factor
 A : area
 T_{out} : gas temperature
 m : gas mass

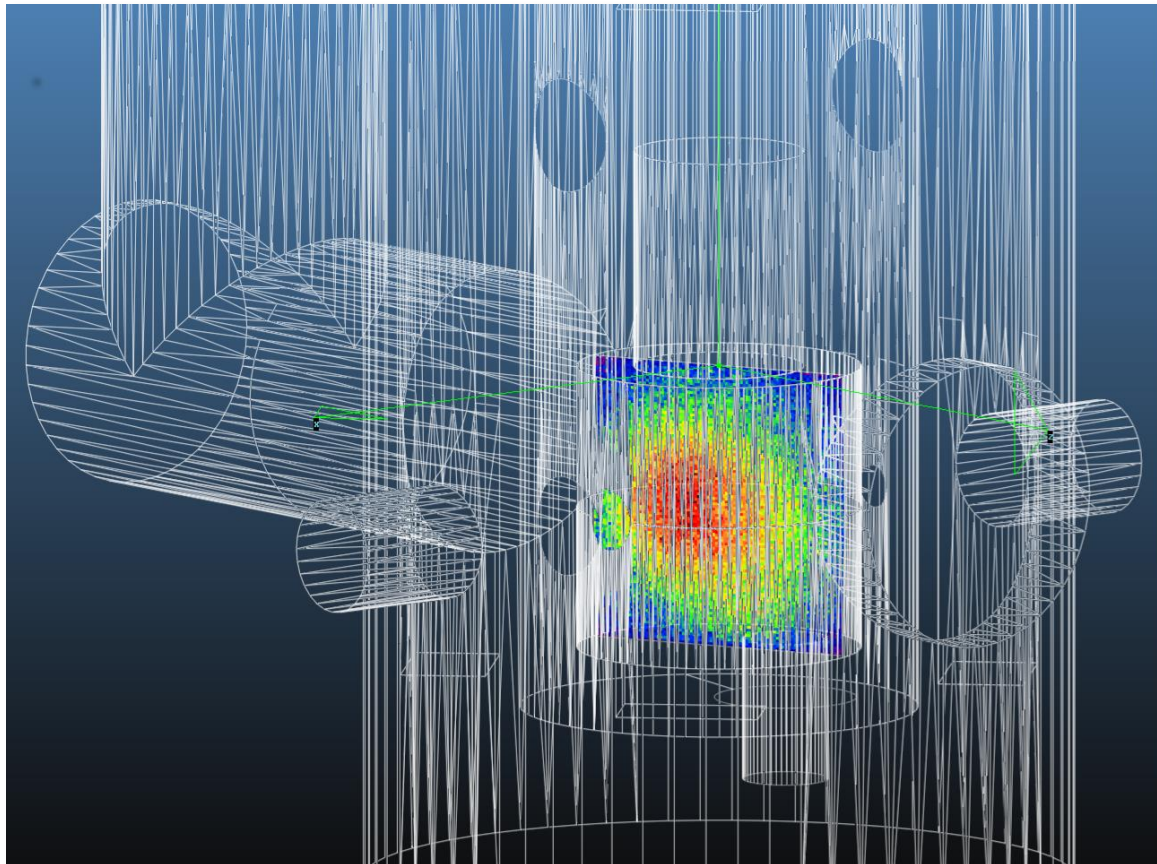
5 K: > 18000 l/s
7 K: > 15000 l/s
12 K: > 8900 l/s
for Hydrogen

$$Q = 1000\frac{\pi d^3}{12l}\sqrt{\frac{8k_bT_{out}}{m\pi}}$$

$$\frac{p_{in}}{p_{out}} = \frac{Q}{S}$$

5 K: > 5.1×10^{-4}
7 K: > 6.2×10^{-4}
12 K: > 1.0×10^{-3}

Prevacuum Simulations



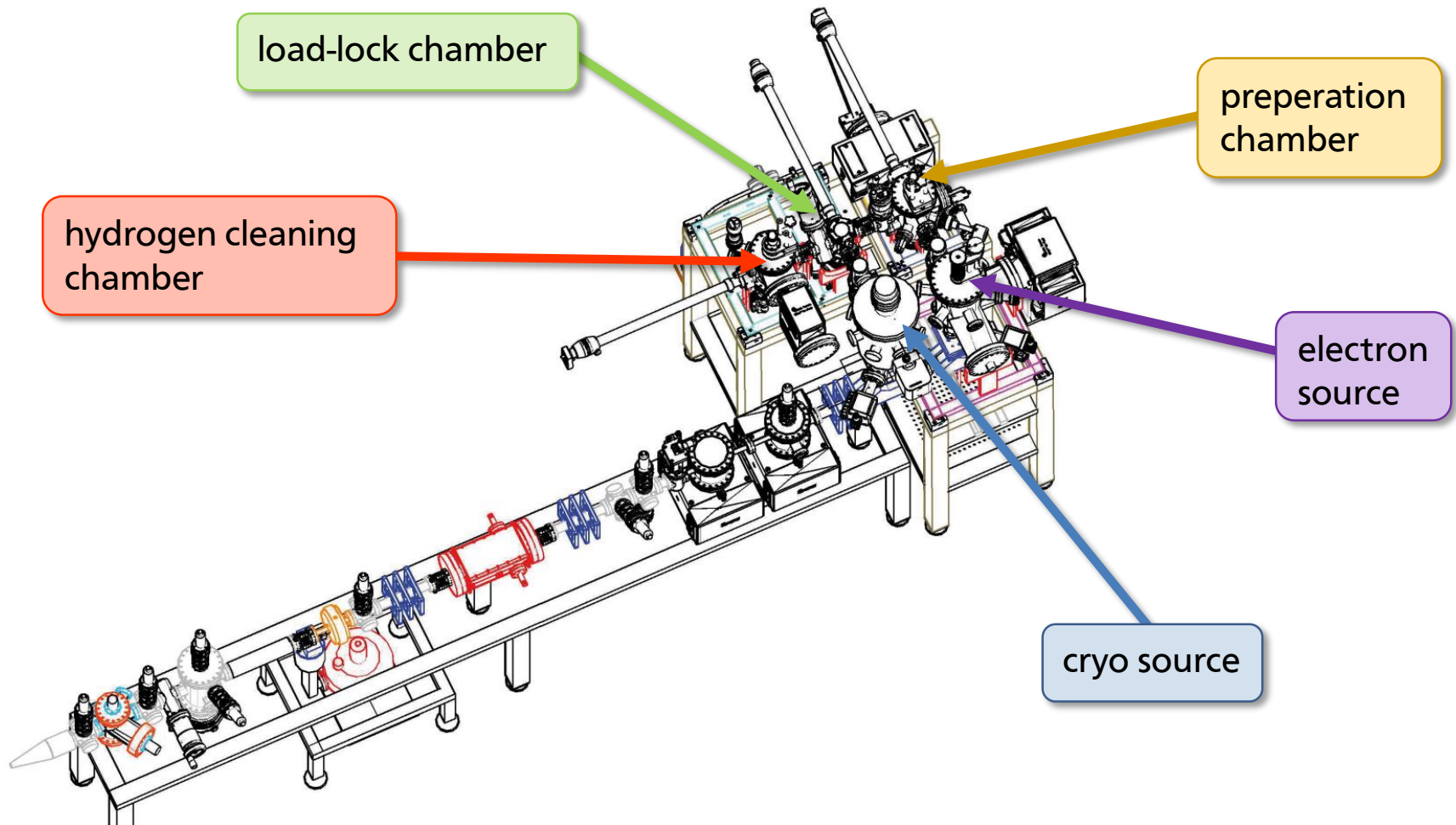
5 K: 2.5×10^{-15} mbar
7 K: 3×10^{-15} mbar
12 K: 5×10^{-15} mbar



5.1×10^{-12} mbar

5.8×10^{-12} mbar

Experimental setup at Photo-CATCH in Darmstadt



Current state and outlook

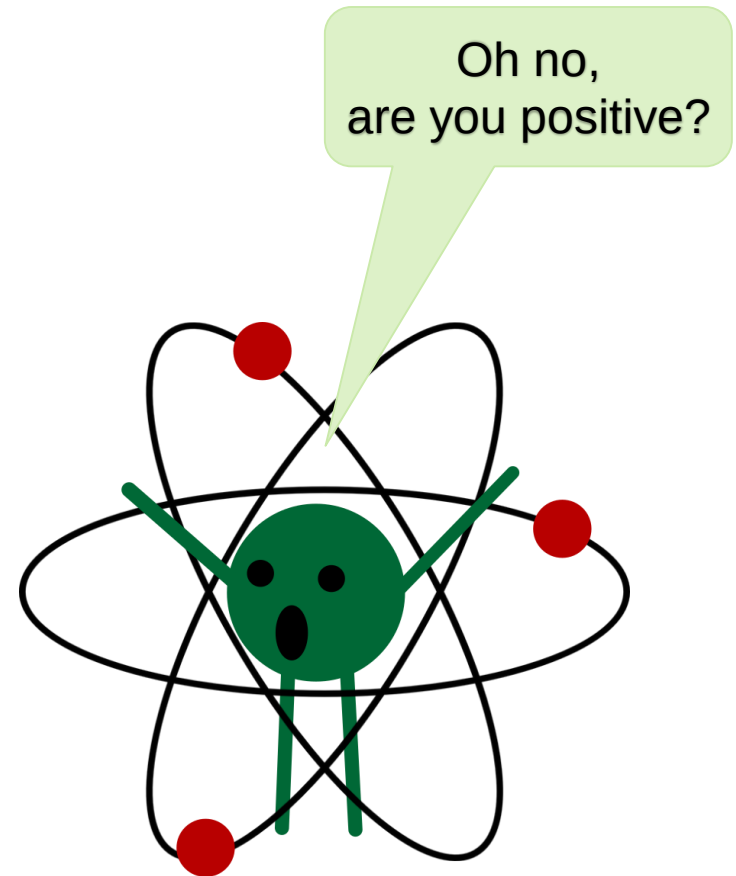
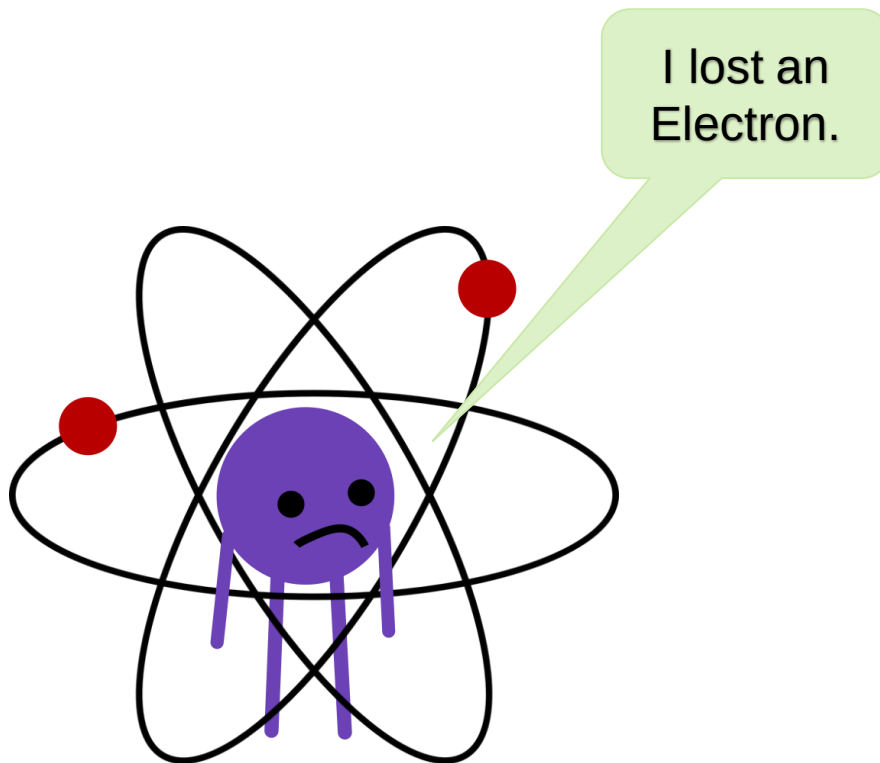
Done

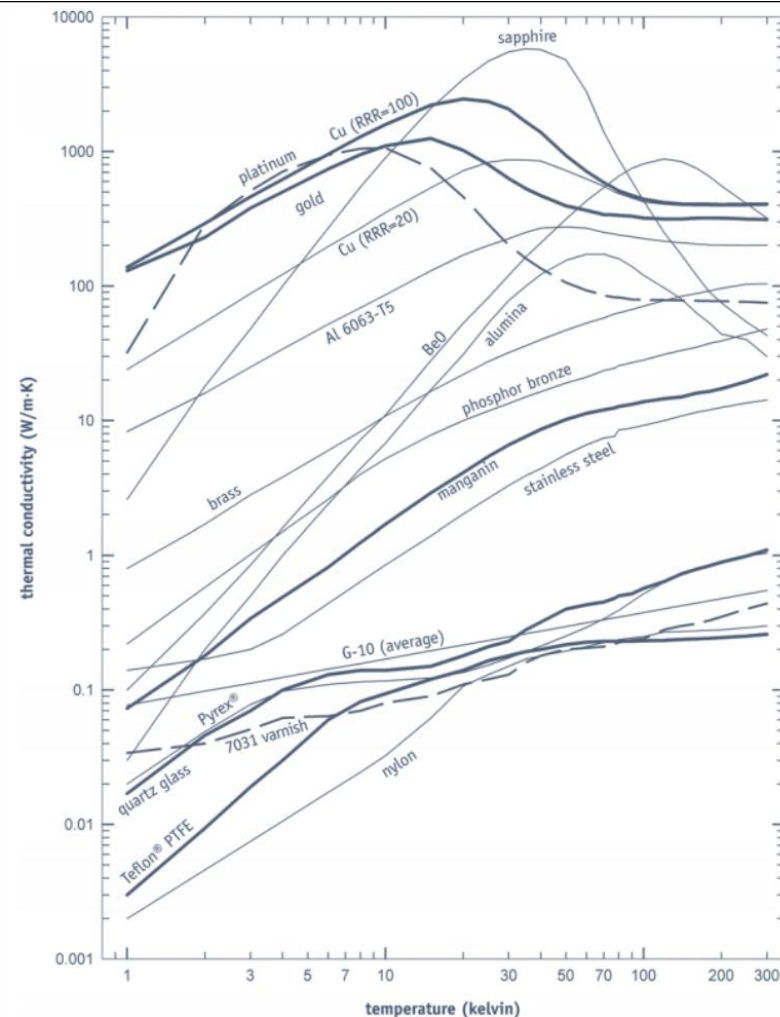
- Cryocooler
- Design of inner chamber
- Ordered inner chamber
- Test stand for setup is available

To DO

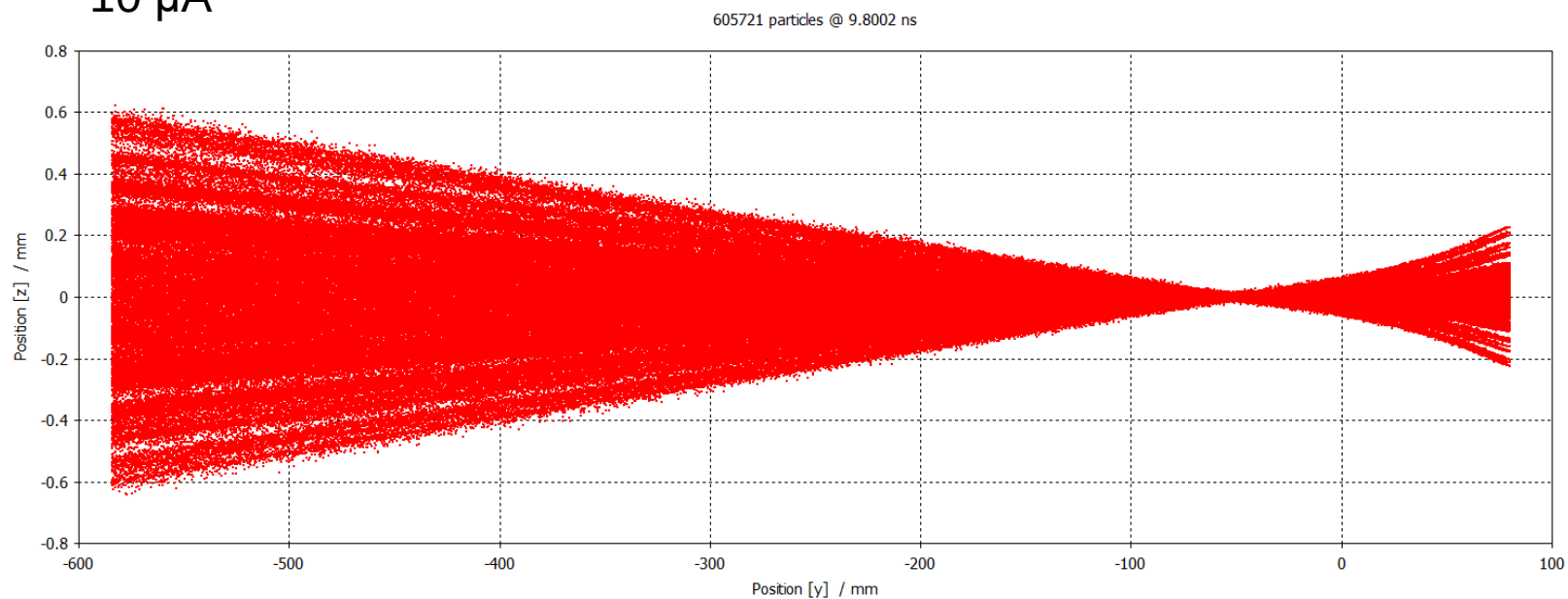
- Design outer chamber
- Modification of Photo-CATCH
- Commissioning of the source

Thank you for your attention

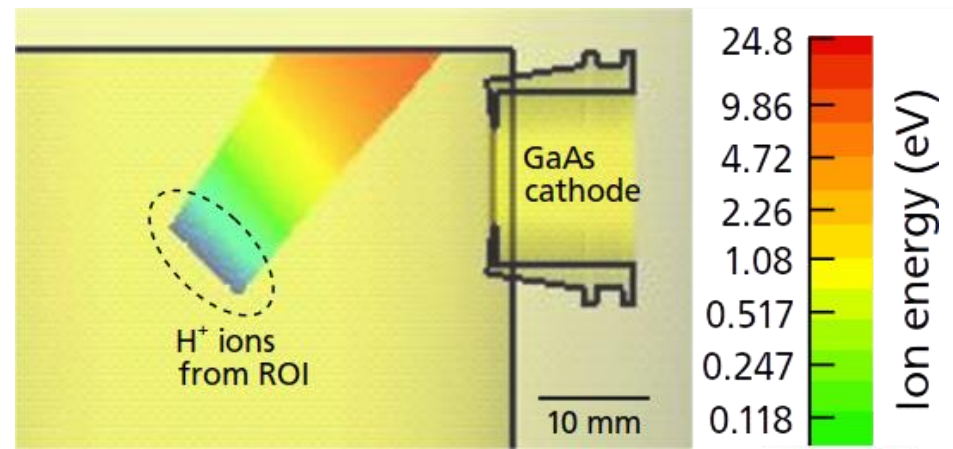
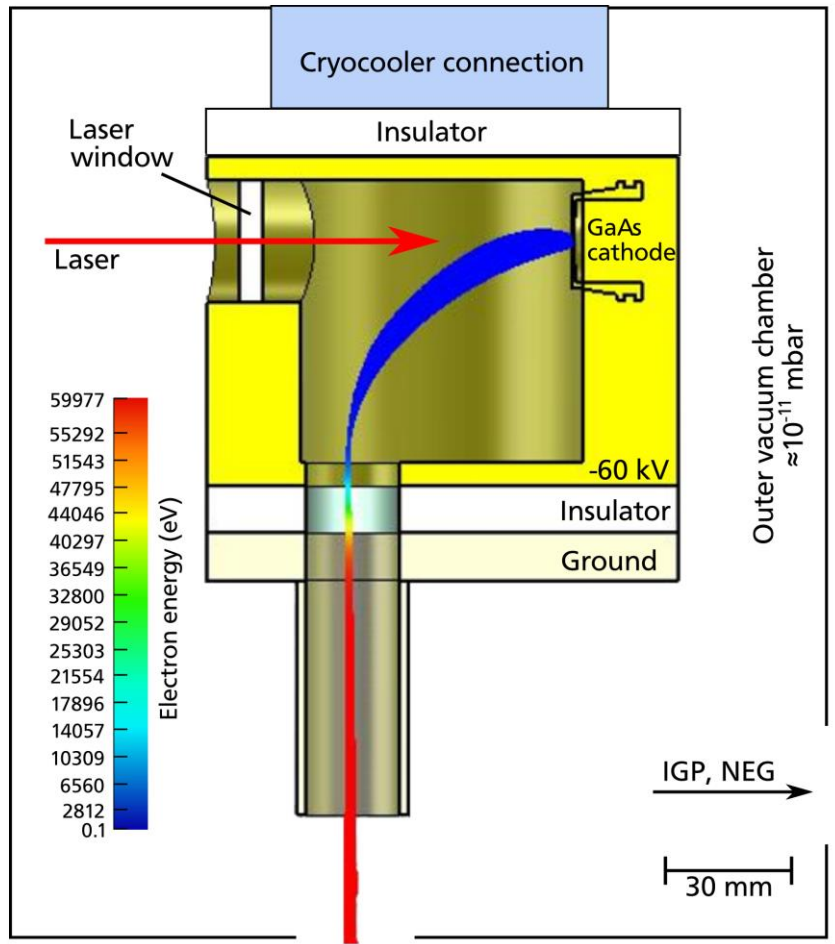




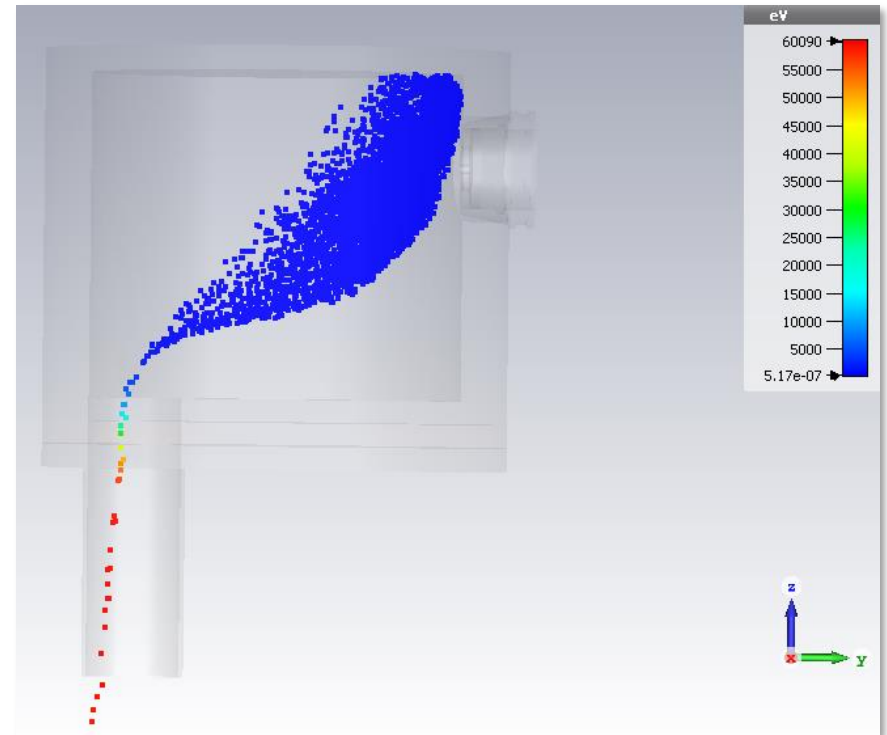
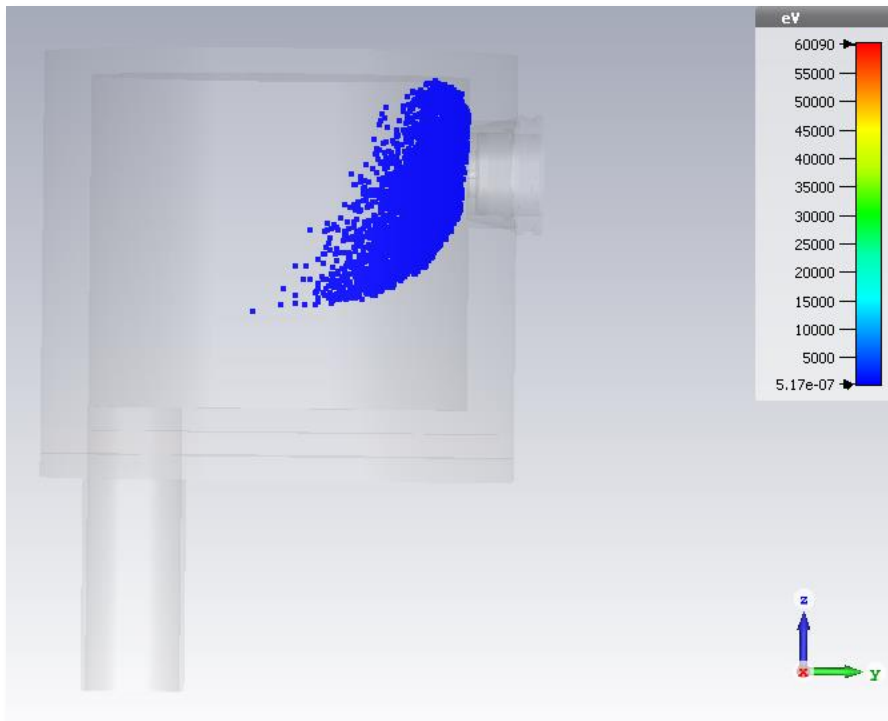
10 μA



Original Design



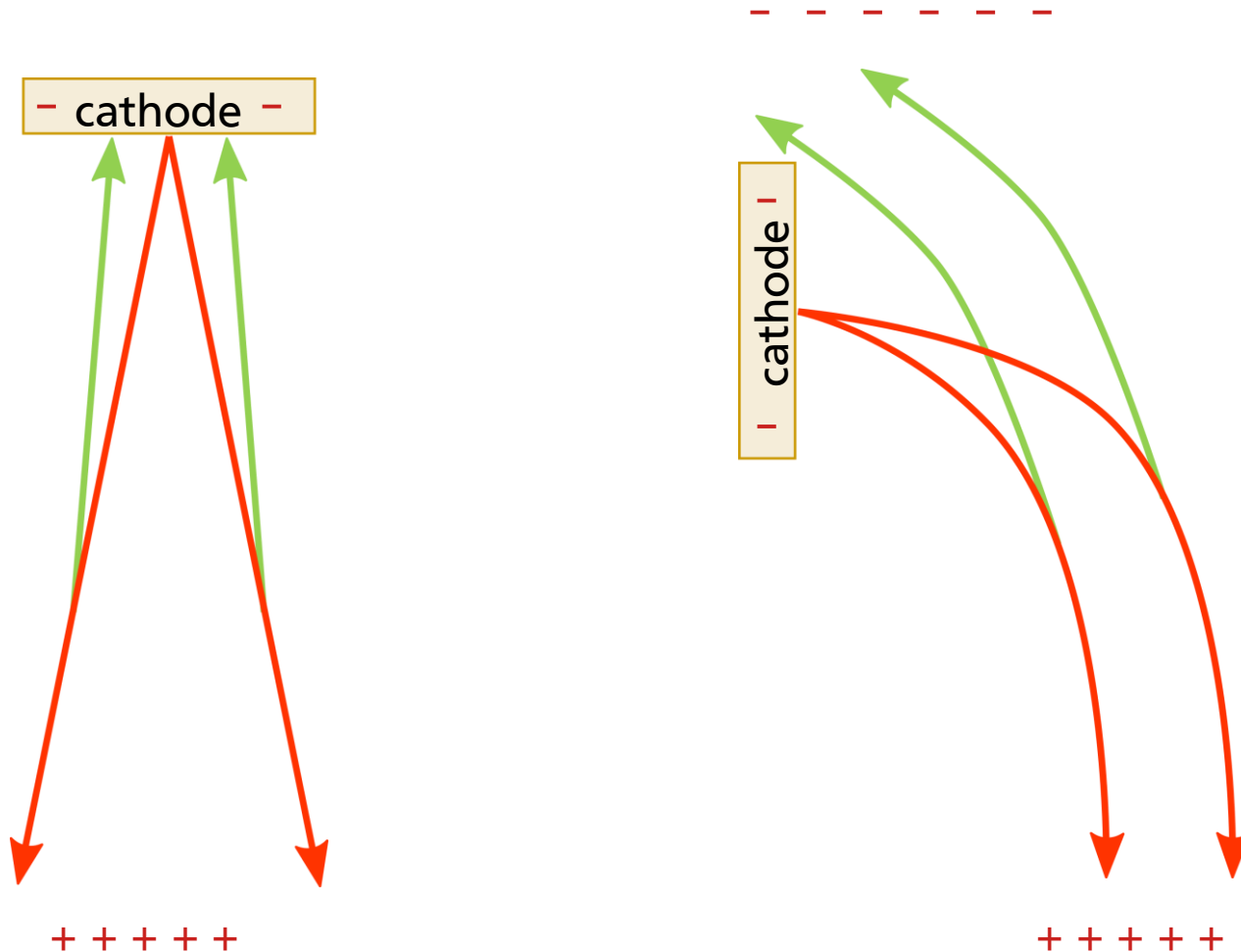
Original Design



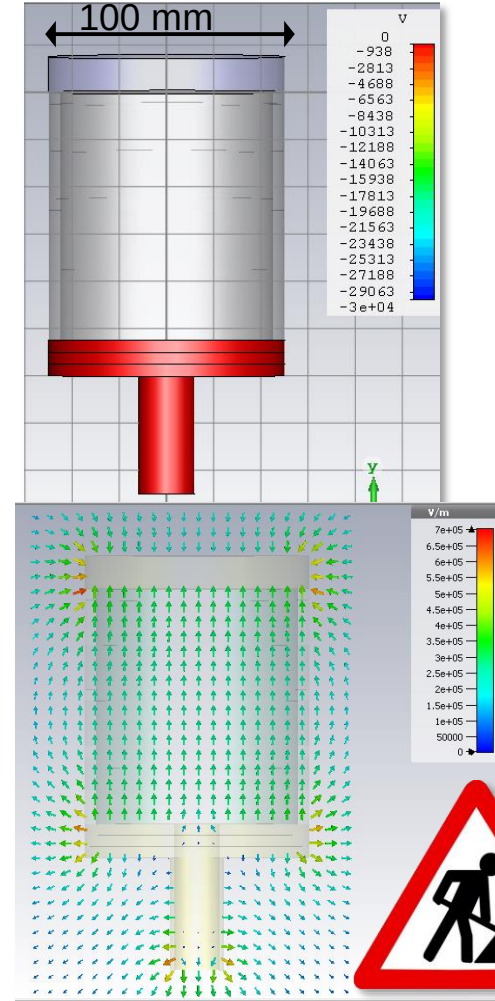
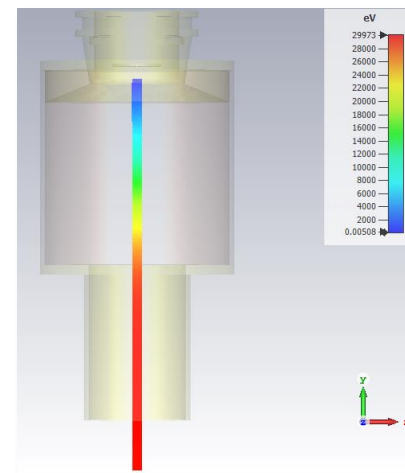
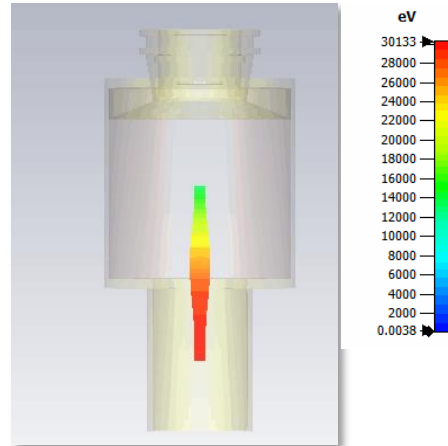
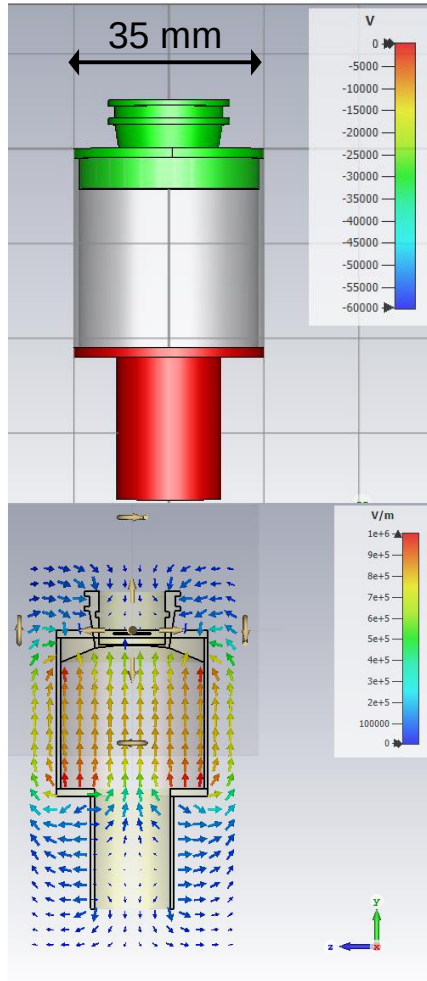
Ion back bombardment



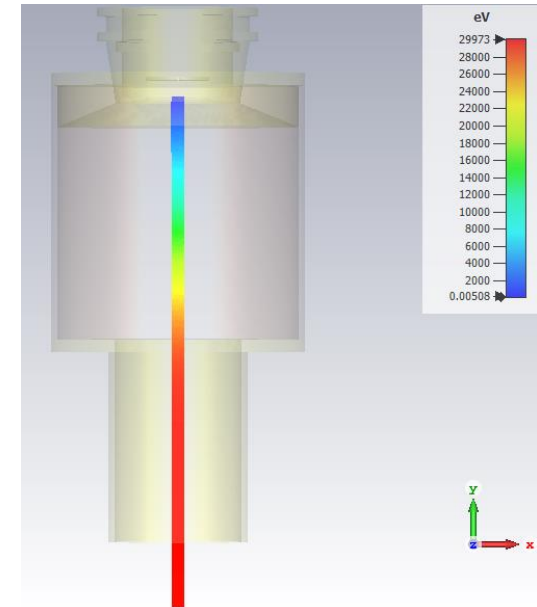
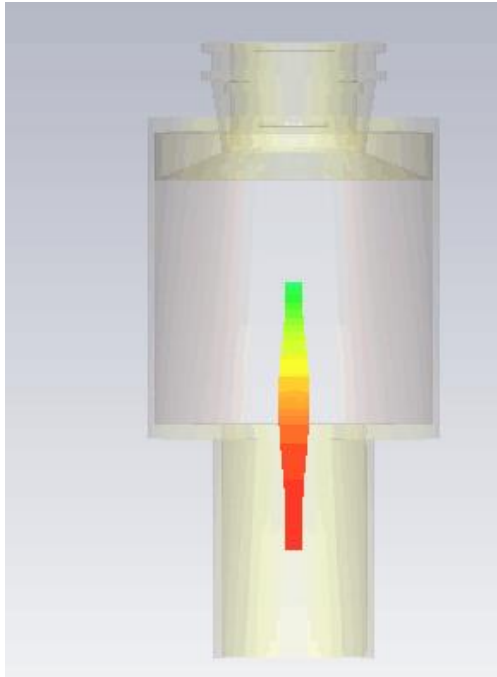
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Ongoing Design Studies

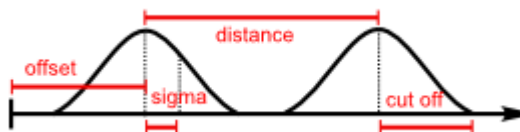


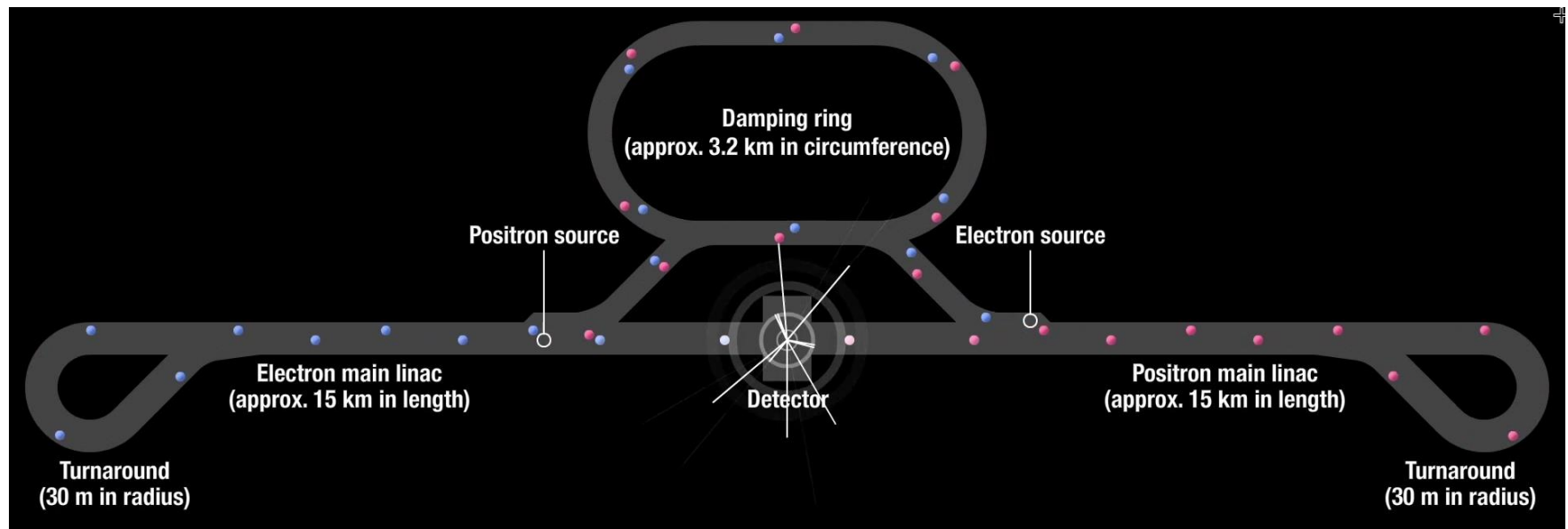
Beam Simulation Parameters

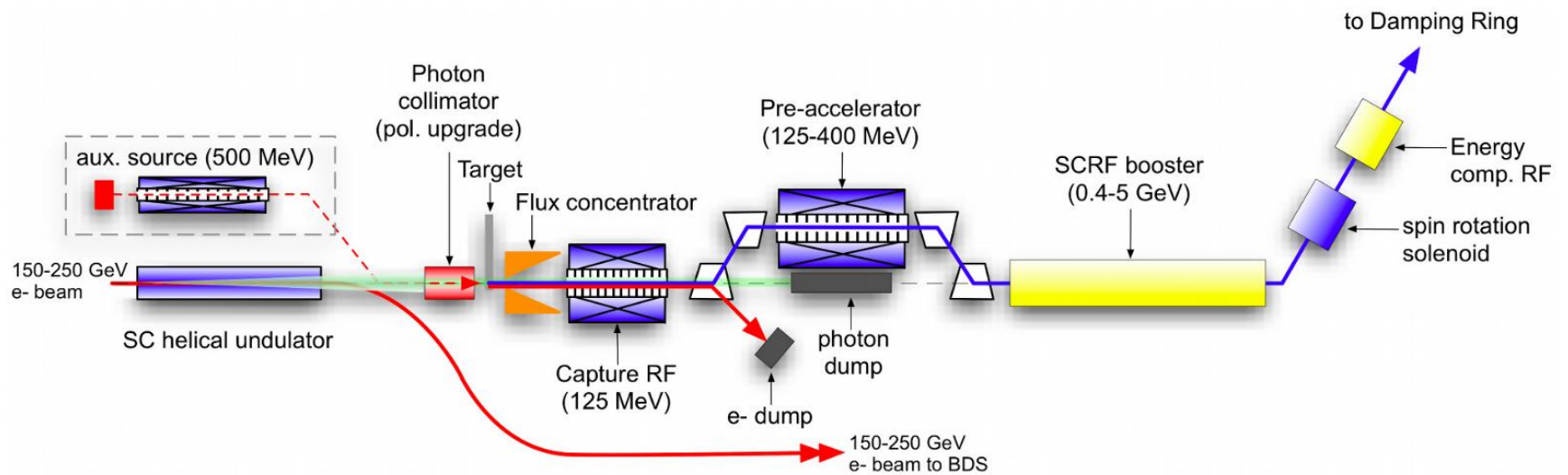


Charge: $1 \cdot 10^{-11} \text{ C}$
Sigma: 0.05 ns
Cutoff length: 0.2 ns
Offset: 0.2 ns
Distance: 1 ns

Current: 1 mA







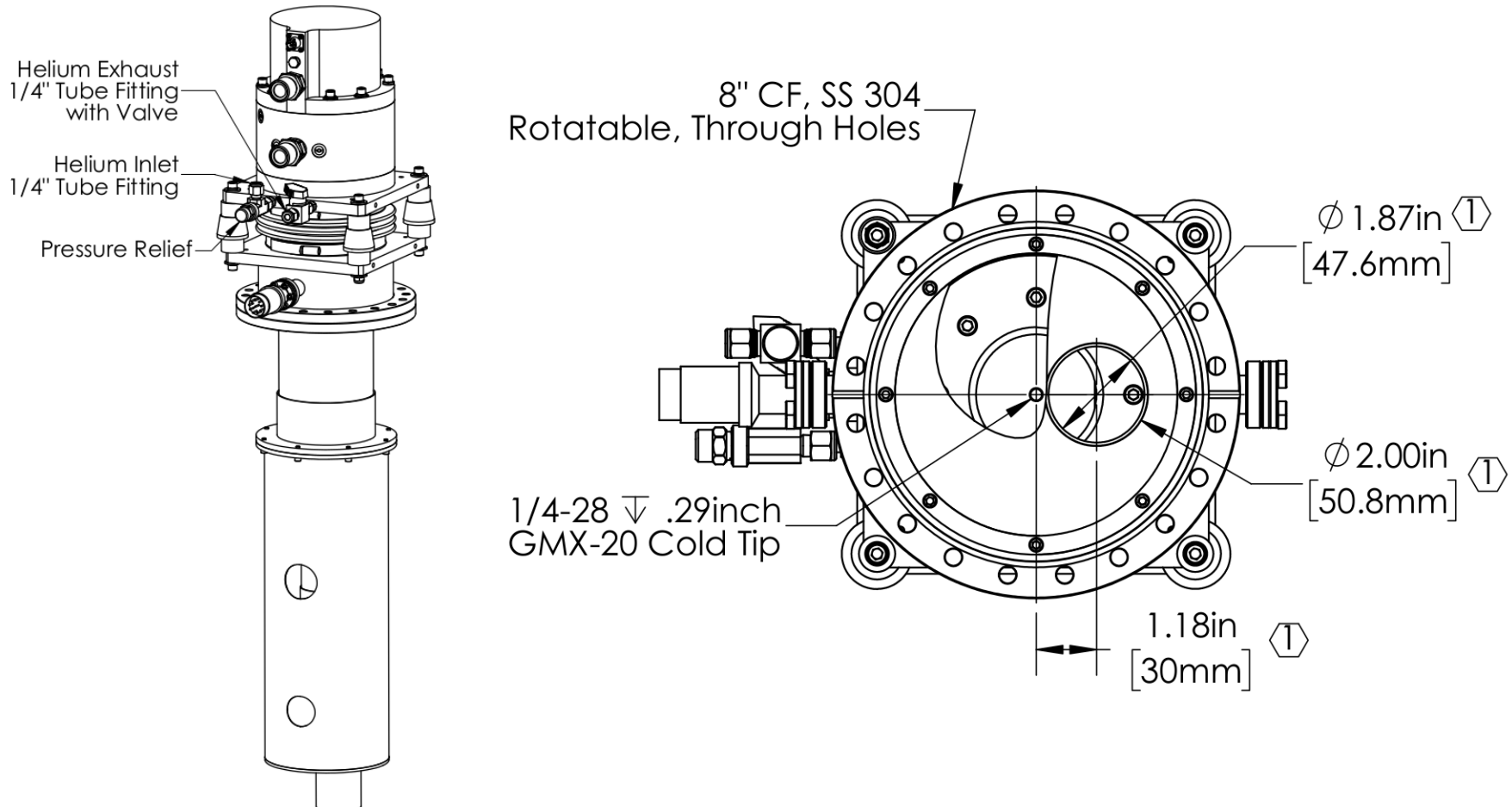
Parameter	Symbol	Value	Units
Positrons per bunch at IP	n_b	2×10^{10}	number
Bunches per pulse	N_b	1312	number
Pulse Repetition Rate	f_{rep}	5	Hz
Positron Energy (DR injection)	E_0	5	GeV
DR Dynamic Aperture	$\gamma(A_x + A_y)$	<0.07	m rad
DR Energy Acceptance	Δ	0.75	%
DR Longitudinal Acceptance	A_l	3.4 x 37.5	cm-MeV
Electron Drive Beam Energy ^a	E_e	150/175/250	GeV
Undulator Period	λ	1.15	cm
Undulator Strength ^b	K	0.92/0.75/0.45	-
Undulator Type	-	Helical	-
Undulator Length	L_u	147	m
Photon Energy (1 st harm cutoff)	E_{c10}	10.1/16.2/42.8	MeV
Photon Beam Power	P_γ	63.1/54.7/41.7	kW
Target Material	-	Ti-6%Al-4%V	-
Target Thickness	L_t	0.4 / 1.4	r.l. / cm
Target Absorption	-	7	%
Incident Spot Size on Target	σ_i	1.4/1.2/0.8	mm, rms
Positron Polarisation	P	31/30/29	%



≈ 20 mA
average current

^aFor centre-of-mass energy below 300 GeV, the machine operates in 10 Hz mode where a 5 Hz 150 GeV beam with parameters as shown in the table is a dedicated drive beam positron source.

^bK is lowered for beam energies above 150 GeV to bring the polarisation back to 30 % without adding a photon collimator before the target.



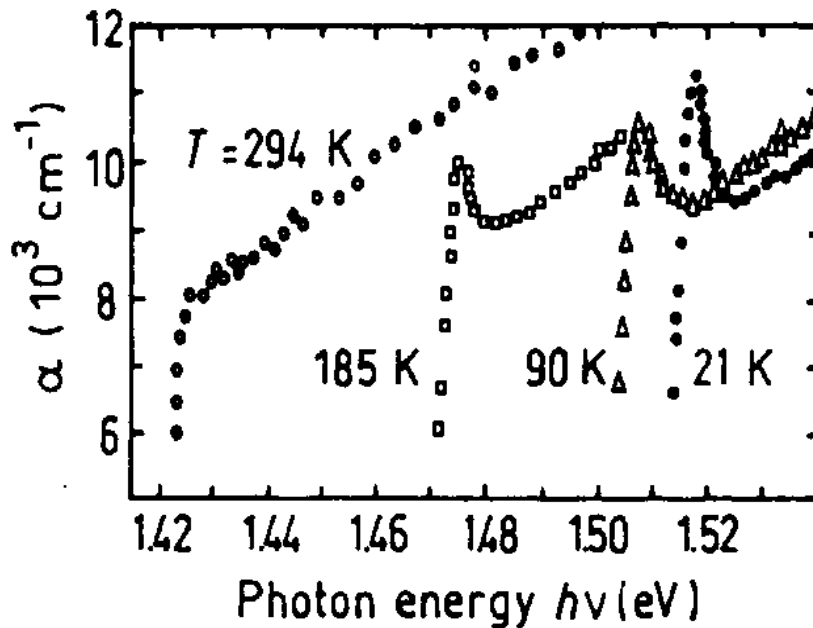
Advantages

- nearly infinite pumping speed for all gases except H₂ and He
- H₂ pumping speed > 10 000 l/s He pumping speed > 1000 l/s

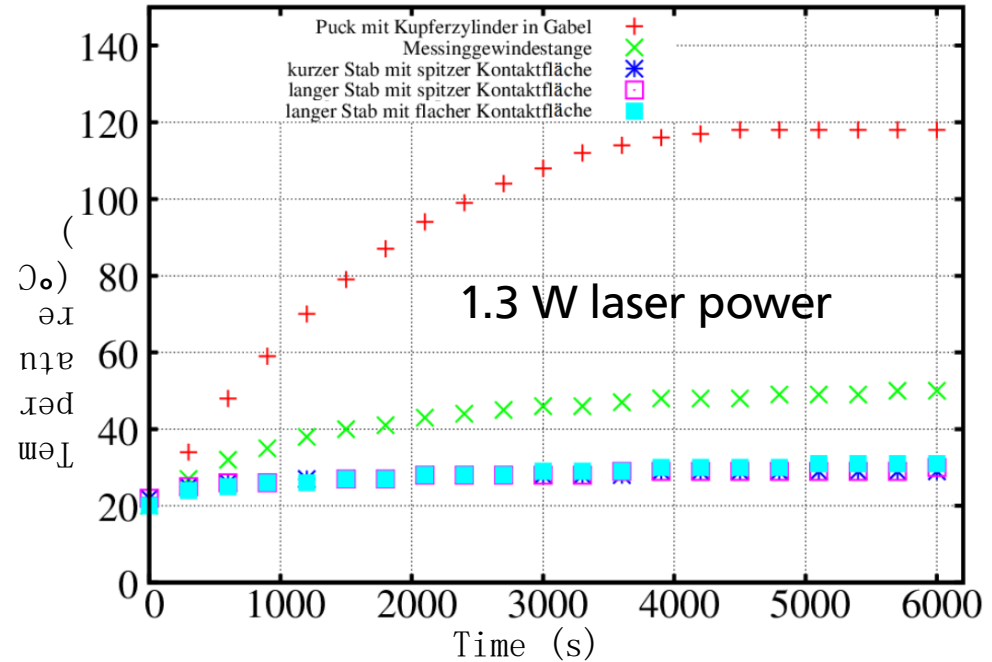
Disadvantages

- Expensive
- No constant pumping speed
- If surface is full with sorbed material no pumping effect
→ use $<10^{-11}$ mbar "prevacuum"
- Even at $p < 10^{-12}$ mbar, outgassing of surrounding walls results in particles inside the chamber
- Particles need time to "find" a pump
→ Let the chamber be the pump

Thermal behavior of GaAs



Sturge, M. D., Phys. Rev. 127, 3 (1962) 768.



Philipp Herrmann, Optimierung der Wärmeleitung von Photokathoden für die Hochstrom-Elektronenquelle von MESA, Diplomarbeit, Johannes Gutenberg-Universität Mainz

ILC Specifications

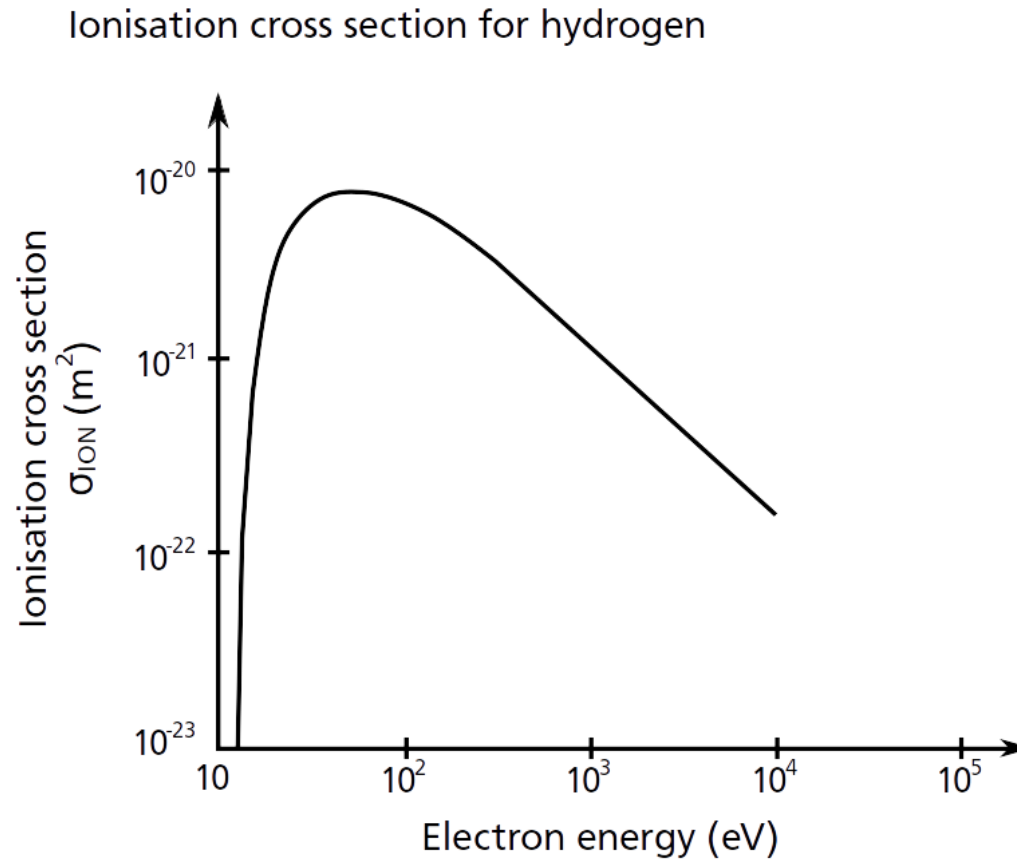


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Beam Parameters	Collision Energy	500 giga-electron-volts (500 GeV = 250 GeV + 250 GeV)
	Luminosity	$2 \times 10^{34} \text{ cm}^{-2} \text{ s}^{-1}$
	Bunch population	2×10^{10}
	Number of bunches	1312
	Bunch spacing	554 ns
	Number of collision	6560 s^{-1}
	Number of beam acceleration	5 s^{-1}
	Acceleration gradient	31.5 MV/m
	Beam size at collision point	Width 474 nm
	Number of acceleration cavity unit	Thickness 5.9 nm
Accelerator unit	Number of cryomodules	14742
	Number of klystrons in distributed klystron system	1701 378
	Size of cryomodule	1m diameter, 12m length
Cryomodule	Cryomodule type	
	Type 1	9 units of 9-cell acceleration cavities
	Type 2	8 units of 9-cell acceleration cavities + 1 unit of superconducting quadrupole magnet
Operation	Frequency of pulsed RF	1.3 GHz
	Power of pulsed RF	190 kW/cavity
	Operation temperature of acceleration cavity	2 K
Size of accelerator	Circumference of Damping ring	3.2 km
	Length of main linac	11 km (electron linac) + 11 km (positron linac)
Collision experiment	Number of Detectors	2 (push-pull alternation)



Ionisation cross section



PMS.IITK.ERNET.IN, Collisional processes in plasmas